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(54) **SUBSTRATE SUPPORTING VIBRATION STRUCTURE, INPUT DEVICE HAVING HAPTIC FUNCTION, AND ELECTRONIC DEVICE**

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(57) **ABSTRACT**

There is provided a substrate supporting vibration structure which is a vibration structure for supporting a substrate. The substrate supporting vibration structure includes a spacer member, fixed between a first substrate and a second substrate, having at least one form selected from a pillar form and a long strip form; and a piezoelectric element, formed at a predetermined position between the first substrate and the second substrate or at a predetermined position of the long strip-form portion of the spacer member, having a vibration supporting portion and a vibration applying portion. In the structure, the vibration supporting portion and vibration applying portion of the piezoelectric element are disposed in the thicknesswise direction of the first and second substrates stacked.

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